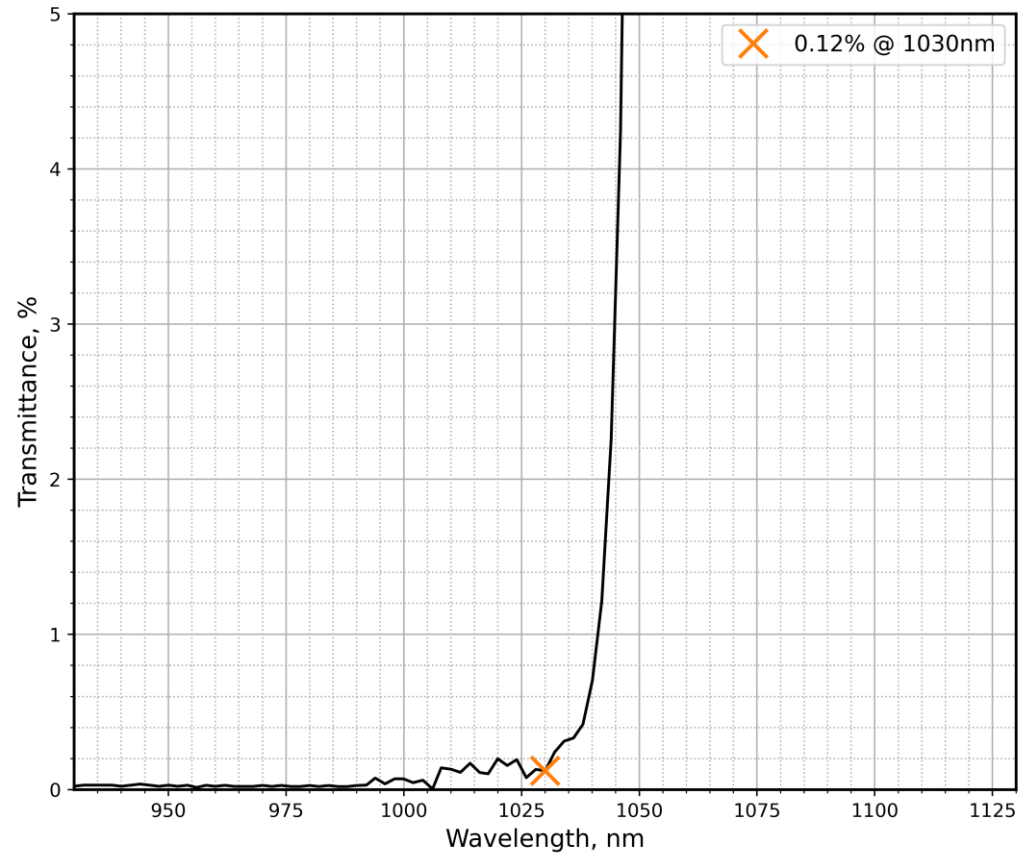


S1: $R_s > 99.9\%$ @ 1030 nm + $T_p > 98\%$ (>99% best efforts) @ 1030 nm, AOI=45 deg +/-1 deg
S2: SCC + $AR_p < 0.1\%$ @ 1030 nm, AOI=45 deg +/-1 deg



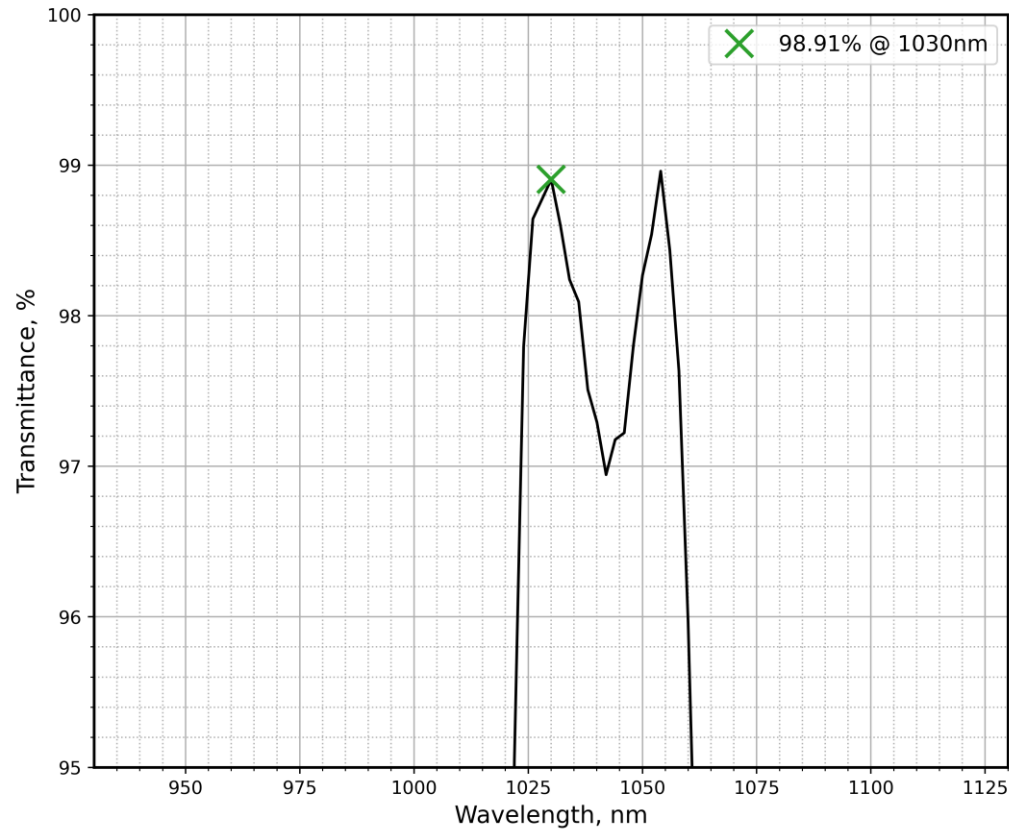
PO4672 Ts i45

Fig. 1.

SIDE MEASURED: S1+S2 (good component)

COMMENTS: Margin of measurement error: +/-0.25%

S1: $R_s > 99.9\%$ @ 1030 nm + $T_p > 98\%$ (>99% best efforts) @ 1030 nm, AOI=45 deg +/-1 deg
S2: SCC + ARp < 0.1% @ 1030 nm, AOI=45 deg +/-1 deg



PO4672 Tp i45

Fig. 2.

SIDE MEASURED: S1+S2 (good component)

COMMENTS: Margin of measurement error: +/-0.25%